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Response under 37 C.F.R. 1.116
 Expedited Procedure Requested
 Examining Group. 1725

Attorney Docket No. P21198

In re application of : Izuru NAKAI et al.

Serial No. : 09/892,651

Group Art Unit: 1725

Filed : June 28, 2001

Examiner: Len Tran

For : LASER PROCESSING APPARATUS AND METHOD

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COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, Virginia 22313-1450

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Sir:

Transmitted herewith is an Amendment under 37 C.F.R. 1.116 in the above-captioned application.

- ___ Small Entity Status of this application under 37 C.F.R. 1.9 and 1.27 has been established by a previously filed statement.
- ___ A verified statement to establish small entity status under 37 C.F.R. 1.9 and 1.27 is enclosed.
- ___ A Request for Extension of Time.
- ☒ No Additional Fee.

The fee has been calculated as shown below:

Claims After Amendment	No. Claims Previously Paid For	Present Extra	Small Entity		Other Than A Small Entity	
			Rate	Fee	Rate	Fee
Total Claims: 10	*20	0	x 9=	\$	x 18=	\$0.00
Indep. Claims: 6	*6*	0	x 42=	\$	x 84=	\$0.00
Multiple Dependent Claims Presented			+140=	\$	+280=	\$0.00
Extension Fees for Month				\$		\$0.00
Total:				\$	Total:	\$0.00

*If less than 20, write 20

**If less than 3, write 3

___ Please charge my Deposit Account No. 19-0089 in the amount of \$_____.

N/A A Check in the amount of \$_____ to cover the filing/extension fee is included.

☒ The U.S. Patent and Trademark Office is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-0089.

☒ Any additional filing fees required under 37 C.F.R. 1.16.

☒ Any patent application processing fees under 37 C.F.R. 1.17, including any required extension of times fees in any concurrent or future reply requiring a petition for extension of time for its timely submission (37 CFR 1.136)(a)(3)

[Signature]
 Bruce H. Bernstein
 Reg. No. 29,027



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(NE.) 1)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Izuru NAKAI et al.

Group Art Unit: 1725

Appln No. : 09/892,651

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For : LASER PROCESSING APPARATUS AND METHOD

RESPONSE UNDER 37 C.F.R. §1.116

Commissioner of Patents
Alexandria, VA. 22313

Sir:

Responsive to the Office Action mailed by the U.S. Patent and Trademark Office on April 8, 2003, in which the three month shortened statutory period for responding runs to July 8, 2003, re-examination and allowance of the present application is respectfully requested in view of the following:

IN THE CLAIMS

Please amend the claims, as follows. A marked-up copy of the claims is attached hereto as "APPENDIX A - MARKED-UP CLAIMS".

Please amend claim 1, as follows:

1 (Twice Amended). A laser processing apparatus, comprising:

a laser oscillator that emits laser light;

an fθ lens positioned relative to the laser oscillator that converges said emitted